



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: application of:

WANG

Serial No.: 10/052,475

Filed: January 17, 2002

Title: ADVANCED CHEMICAL  
MECHANICAL POLISHING SYSTEM WITH  
SMART ENDPOINT DETECTION

Group Art Unit: 3723  
Examiner: D. Thomas  
Docket: NT-238-US

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being  
deposited with the US Postal Service as First Class Mail in  
a postage-paid envelope addressed to the Commissioner  
for Patents, P.O. Box 1450, Alexandria, VA 22313 on  
December 3, 2003.

Signed:

Amy A. Wine

AMENDMENT B

Commissioner for Trademarks  
P.O. Box 1450  
Alexandria, VA 22313

**RECEIVED**

**DEC 10 2003**

TECHNOLOGY CENTER R3700

Dear Sir:

In response to the Office Action mailed September 8, 2003, Applicant petitions for entry and consideration of the following Remarks and Amendment. Please amend the above-identified application as follows:

The Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.